

THE UNIVERSITY OF ALABAMA IN HUNTSVILLE



MOORE NANOTECH 250 UPL

SINGLE POINT DIAMOND TURNING MACHINE WITH HIGH RESOLUTION ENCODER AND 100MM RISER PROGRAMMING RESOLUTION OF .01 NM LINEAR



ZEEKO ULTRA-PRECISION IRP600

7 AXIS NC POLISHING MACHINE. WORKPIECE CAPACITY OF 900MM OD OR FREE-FORM 600MM SQUARE. SURFACE FINISH LESS THAN 3 ANGSTROMS (SPECIFIC MATERIAL)



DESIGN & ENGINEERING

PARTNERS FROM DESIGN TO DELIVERABLE PRODUCTS OPTICAL DESIGN AND ANALYSIS USING CODE V, ZEMAX, ASAP, FRED



PROCUREMENT & ITAR

CLASS 100 LAMINAR FLOW BOOTH, DESIGNATE CLASS 1,000 CLEAN ROOMS, REGISTERED AS ITAR COMPLIANT, CAN IMPLEMENT SPC STANDARDS.



NANO-MICRO DEVICES CENTER

7,000 SQFT CLASS 10,000 CLEANROOM, CLASS 1,000 OR LESS IN LITHOGRAPHY AREA. FULL COMPLEMENT OF EQUIPMENT WITH ACCESS FOR INDUSTRIAL USERS

DESIGN & ENGINEERING



SPECIFICATIONS

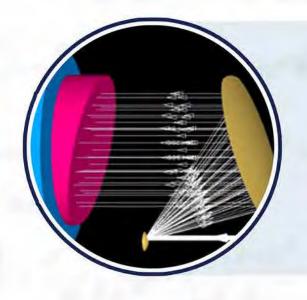
PARTNERS FROM DESIGN TO DELIVERABLE PRODUCT

OPTICAL DESIGN AND ANALYSIS USING CODEV, ZEMAX, ASAP, FRED.

MECHANICAL DESIGN WITH FEA ANALYSIS USING IDEAS

OPTICAL TESTING AND METROLOGY USING ZYGO, WYKO AND HOLOGRAPHIC

SERVING CUSTOMERS SUCH AS NASA, DEFENSE, COMMERCIAL AEROSPACE AND PRIVATE INDUSTRY



SERVICES OFFERED @ CAO

Optical Design & Analysis
Optical Testing and Metrology
Optical Materials & Fabrication
Opto-Mechanical Design Analysis
Optical Image Processing
Optical Instrument Development

SOFTWARE & MODELING TOOLS

SOLID EDGE, CODE V, ZEMAX, PRO-E, WYKO-VISION PHASESHIFT, ZYGO, RHINO 3D, DIFFSYS

MOORE NANOTECH 250 UPL



WORKPIECE CAPACITY OF 350MM

-C- AXIS ROTARY WITH POSITION ERROR OF .4 ARC SECONDS

FORM ERROR OVER 75MM DIA CONVEX SPHERE LESS THAN 0.08 MICRONS

SURFACE ROUGHNESS LESS THAN 1NM ON ALUMINUM

HIGH RESOLUTION ENCODER WITH PROGRAMMING RESOLUTION OF .01 NM LINEAR



SHAPES

Plano Spheres Parabola / Hyperbola Conical Free Form

MATERIALS

ALUMINUM, NICKEL, COPPER PLASTICS, CRYSTALS

NANO-MICRO DEVICES CENTER

7,000 SQFT CLASS 10,000 CLEANROOM
CLASS 1,000 OR LESS IN LITHOGRAPHY AREA
FULL COMPLEMENT OF EQUIPMENT
LITHOGRAPHY
SPUTTERING AND EVAPORATION
WET/DRY ETCHING
SEM WITH EDX
CONTACT AND OPTICAL METROLOGY
ACCESS FOR INDUSTRIAL USERS
FULL ACCESS DURING STANDARD WORK HOURS
CAN ACCOMMODATE NEEDS FOR PROPRIETARY/ ITAR WORK

CAN HANDLE UNUSUAL MATERIALS AND/OR PROCESSING







PROCUREMENT & ITAR

OPERATING PRACTICES

Class 100 Laminar Flow Booths

Designated Class 1,000 Clean Rooms

Registered as ITAR Compliant

Can Implement ISO Standards on Specific Customer Demand

Can Implement SPC Standards

Revision Controlled Documents and/or Drawings as needed



PROCUREMENT SERVICES

PROCUREMENT OF RAW MATERIAL
MACHINING OF PRODUCT
OPTICAL COATING
HEAT TREAT AND/OR
THERMAL CYCLING

CHEMICAL PROCESSING

ELECTROLESS NICKEL PLATING, CONVERSION COATINGS, ANODIZE

ZEEKO IRP 600X

ULTRA-PRECISION POLISHING MACHINE

SPECIFICATIONS

WORKPIECE CAPACITY OF 900MM OD OR FREE-FORM 600MM SQUARE



FORM ERROR OVER LESS THAN 1/20 WAVE P-V

CORRECTIVE AND FINISH POLISHING, JET POLISHING FOR SMOOTHING

SPIRAL/RASTER/RANDOM TOOL PATH, INCORPORATE CMM DATA OR INTERFEROMETRIC MAPS



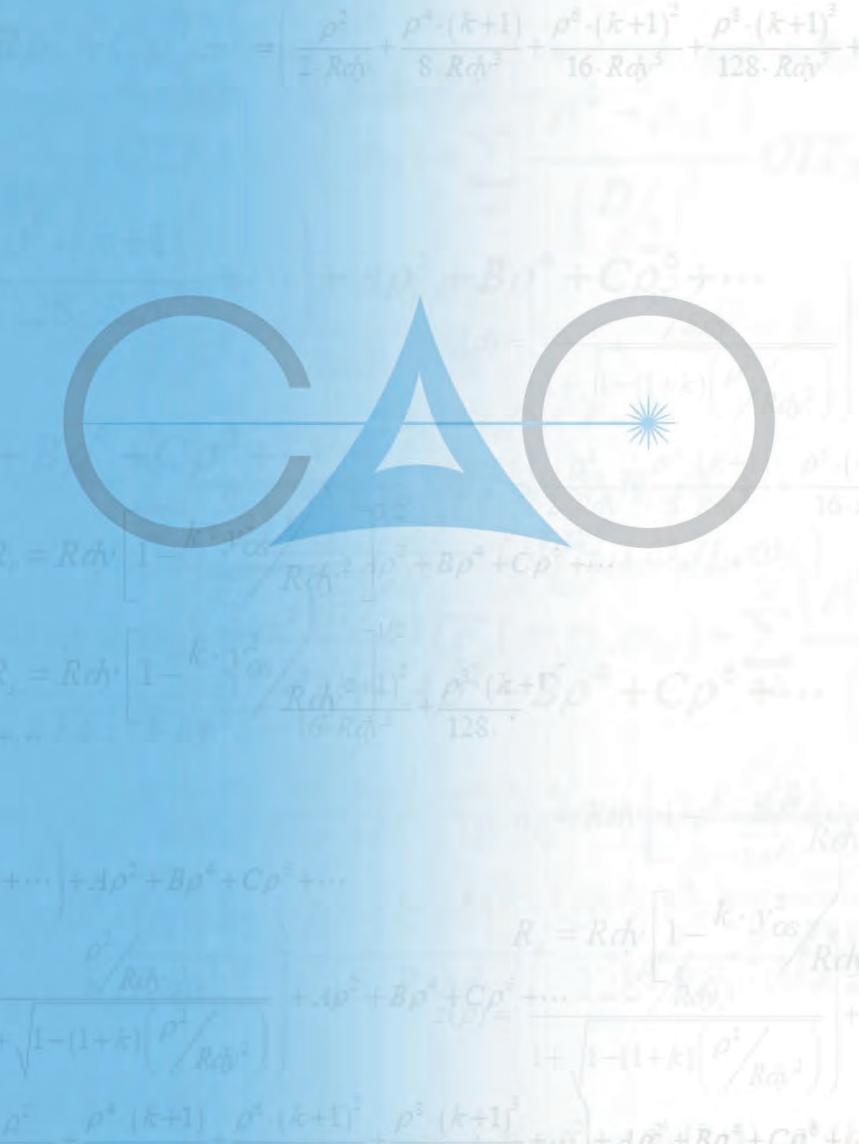
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Plano Spheres Parabola / Hyperbola Conical Free Form

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